

& I^{OK} TO ENTER: /SM/ 03/10/2009



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 4044

Akihisa HONGO et al.

Attorney Docket No. 2003_1822A

Serial No. 10/735,771

Group Art Unit 1792

Filed December 16, 2003

Examiner Sylvia R. MacArthur

SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD

Mail Stop AF

REQUEST FOR RECONSIDERATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action mailed November 24, 2008, reconsideration of the rejections therein is respectfully requested for the following reasons.